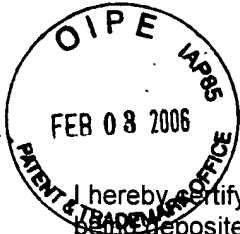


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Maria T. Sanchez
(Print Name)

Date: February 1, 2006

Maria T. Sanchez
(Signature)

Docket No. 2002JP317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application

Akihiko IGAWA and Atsuko YAMAMOTO

Art Unit: To be Assigned

Serial No. 10/534,551, filed May 10, 2005

Examiner: To be Assigned

For: **METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT POSITIVE PHOTOSENSITIVE COMPOSITION**

**INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING
OR BEFORE MAILING OF THE FIRST OFFICE ACTION
(37 CFR 1.97 (b))**

February 1, 2006

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

1. IDENTIFICATION OF TIME OF FILING INFORMATION DISCLOSURE
STATEMENT

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 CFR 1.97(b).

2. PRELIMINARY STATEMENTS

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

Pursuant to the notice in the Official Gazette notice of 5 August 2003, 1276 O.G. 55, copies of US Patents and/or US Patent Publications are not being enclosed as the present application has a filing date after June 30, 2003.

3. COMPLETED FORM PTO-1449 IS ATTACHED.

4. IDENTIFICATION OF PRIOR APPLICATION IN WHICH LISTED INFORMATION
WAS ALREADY CITED AND FOR WHICH NO COPIES ARE SUBMITTED OR NEED
BE SUBMITTED

[] This application relies, under 35 U.S.C. 120, on the earlier filing date of prior application Serial No. _____ filed on _____.

5. COPIES OF LISTED INFORMATION ITEMS ACCOMPANYING THIS
STATEMENT

GB 2 172 117 A
JP 06-35183
JP 54-23570
JP 55-73045
JP 56-30850
JP 61-205933

English Abstract of JP 06-35183
English Abstract of JP 06-43637
English Abstract of JP 07-98503
English Abstract of JP 10-153854
English Abstract of JP 2002-98996
Machine Language English Translation from JPO of 06-35183
Machine Language English Translation from JPO of 06-43637
Machine Language English Translation from JPO of 07-98503
Machine Language English Translation from JPO of 10-153854
Machine Language English Translation from JPO of 2002-98996

Legible copies of all items listed accompany this information statement except as noted herein.

[] Items in prior application from which an earlier filing date is claimed for this application as identified in No. 4 above.

6. TRANSLATION(S) OF NON-ENGLISH LANGUAGE DOCUMENTS

[X] Submitted herewith is an English language abstract of the following foreign language patents, publications or information or of those portions of those patents, publications or information considered to be material:

English Abstract of JP 06-35183
English Abstract of JP 06-43637
English Abstract of JP 07-98503
English Abstract of JP 10-153854
English Abstract of JP 2002-98996

[X] No English language translations of the foreign language patents, publications or information or parts thereof are readily available, except those listed above.

[X] The following foreign language documents submitted are believed to be the equivalent or substantial equivalent of the English language documents identified below, which are also submitted herewith:

GB 2 172 117 A - equivalent to JP 61-205933
US 3666473 - equivalent to JP 54-23570
US 4115128 - equivalent to JP 56-30850
US 4275139 - equivalent to JP 55-73045

Serial No.: 10/534,551
Filed May 10, 2005

Pursuant to the Official Gazette notice of 5 August 2003, 1276 O.G. 55, since this application entered the National Stage under 35 USC 371 after June 30, 2003, applicant is not enclosing copies of the above mentioned U.S. patents and/or U.S. patent publications.

Copies of JP 06-43637, JP 07-98503, JP 2002-98996, and JP 10-153854 are not enclosed as they were cited in the International Search Report submitted with applicants' National Stage filing.

8. IDENTIFICATION OF PERSON(S) MAKING THIS INFORMATION
DISCLOSURE STATEMENT

The person making this statement is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted:

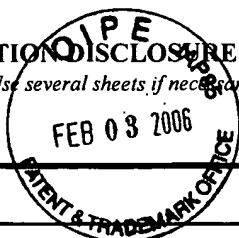


Attorney for Applicant(s)
Alan P. Kass
(Reg. No. 32142)
70 Meister Avenue
Somerville, New Jersey 08876
Telephone: (908) 595-3890
Telefax: (908) 429-3650

Customer No. 26,289

INFORMATION DISCLOSURE CITATION

(Use several sheets, if necessary)



Docket Number (Optional)

2002JP317

Application Number

10/534,551

Applicant(s)

Akihiko IGAWA and Atsuko YAMAMOTO

Filing Date

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		3,666,473	5/30/1972	Colom et al.			
		4,115,128	9/19/1978	Kita			
		4,275,139	6/23/1981	Stahlhofen			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		GB 2 217 117 A	3/4/1986	UNITED KINGDOM				
		JP 6-35183	2/10/1994	JAPAN			✓	
		JP 54-23570	8/15/1979	JAPAN				
		JP 55-73045	6/2/1980	JAPAN				
		JP 56-30850	7/17/1981	JAPAN				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		English Language abstract of JP 6-35183.
		Machine Language English translation from JPO of JP 6-35183.

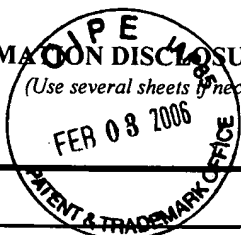
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Docket Number (Optional)

2002JP317

Application Number

10/534,551

Applicant(s)

Akihiko IGAWA and Atsuko YAMAMOTO

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		JP 61-205933	9/12/1986	JAPAN				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		English Language abstract of JP 6-43637.
		Machine Language English translation from JPO of JP 6-43637.

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Docket Number (Optional)

2002JP317

Application Number

10/534,551

Applicant(s)

Akihiko IGAWA and Atsuko YAMAMOTO

Filing Date

Group Art Unit

*EXAMINER
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

English Language abstract of JP 7-98503.

Machine Language English Translation from JPO of JP 7-98503.

English Language abstract of JP 10-153854.

Machine Language English Translation from JPO of JP 10-153854.

English Language abstract of JP 2002-98996.

Machine Language English Translation from JPO of JP 2002-98996.

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Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

Filing Date

May 10, 2005

Examiner

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Invention: **METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION**

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Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

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May 10, 2005

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION

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Applicant(s) Akihiko IGAWA and Atsuko YAMAMOTO				
Serial No. 10/534,551	Filing Date May 10, 2005	Examiner To Be Assigned		Group Art Unit To Be Assigned
Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT POSITIVE PHOTSENSITIVE COMPOSITION				
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

Filing Date

May 10, 2005

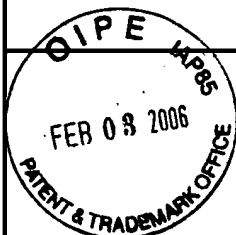
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Invention: **METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION**

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Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

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Invention: **METHOD OF PATTERN FORMATION USING A HIGH HEAT RESISTANT
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Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

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Serial No.

10/534,551

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Invention: METHOD OF PATTERN FORMATION USING STRAIGHT HIGH HEAT RESISTANT
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Applicant(s): Akihiko IGUCHI and Atsuko YAMAMOTO

Docket No.

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Serial No.

10/534,551

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTOCURABLE COMPOSITION

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Applicant(s): Akihiko GAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

Filing Date

May 10, 2005

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Invention: **METHOD FOR PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION**

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Serial No.

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Invention: **METHOD OF PATTERN FORMATION USING A HIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION**

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Applicant(s): Akihiko ICHIO and Atsuko YAMAMOTO		2002JP317	
Serial No. 10/534,551	Filing Date May 10, 2005	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT POSITIVE PHOTSENSITIVE COMPOSITION			
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Applicant(s): Akihiko GAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

10/534,551

Filing Date

May 10, 2005

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION

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Applicant(s): Akihiko GAWA and Atsuko YAMAMOTO

Docket No.

2002JP317

Serial No.

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Invention: **METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION**

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Applicant(s): Akihiko IGAWA and Atsuko YAMAMOTO

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION

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Invention: METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
POSITIVE PHOTSENSITIVE COMPOSITION

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Invention: **METHOD OF PATTERN FORMATION USING ULTRAHIGH HEAT RESISTANT
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